



# Geometry Characterization of Electrodeposition Samples for Spacecraft Docking Application

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# Table of Contents

1. Introduction
2. Experiment
3. Results and Discussion
4. Conclusions
5. Further Investigation



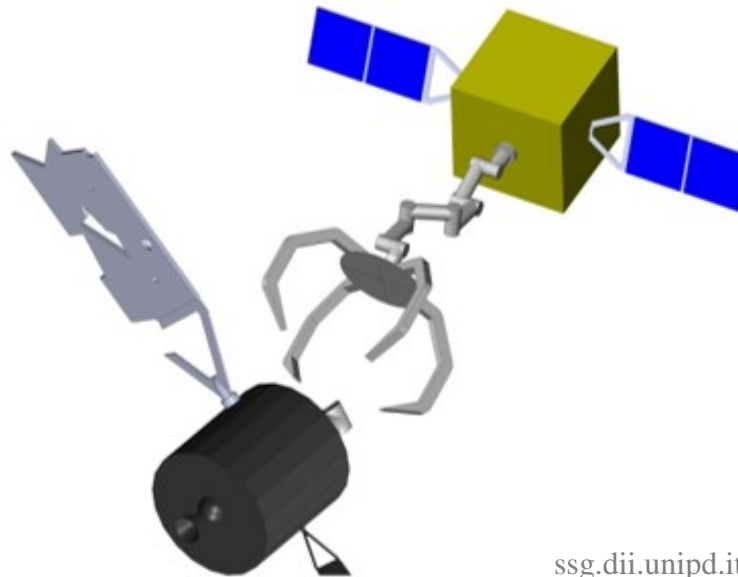
# Table of Contents

1. Introduction
2. Experiment
3. Results and Discussion
4. Conclusions
5. Further Investigation



# Motivation

Docking mechanisms are essential in space missions. Determining a low-risk, low-cost alternative to past docking techniques advances the frontier of space technology.



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Introduction



# Research Objective

Study maximum shear forces of Electrodeposition samples composed of space-rated materials on substrates, test geometries of samples with air-bearing platforms as docking mechanisms, and propose a metric for capturing.

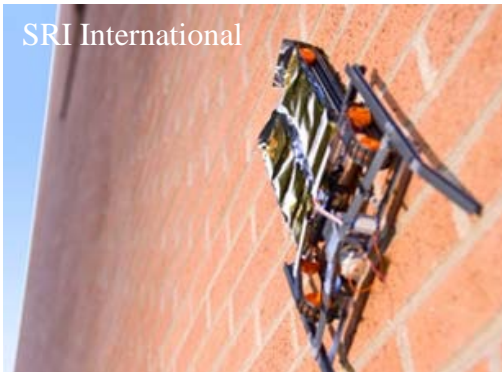


Introduction



# Applications of Electrodeposition

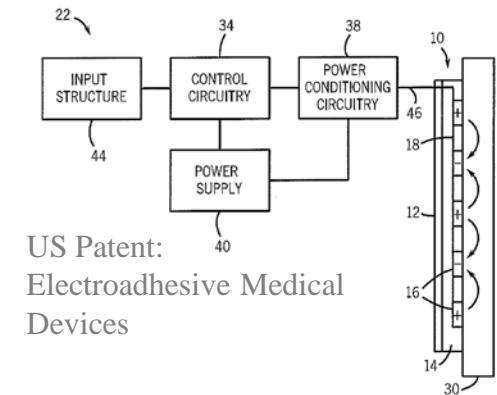
## Industrial



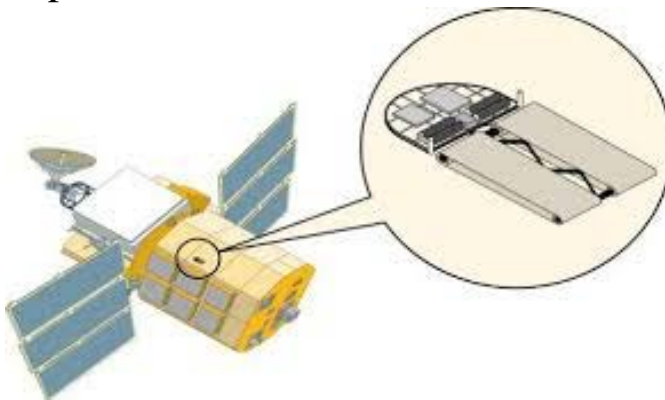
## Military



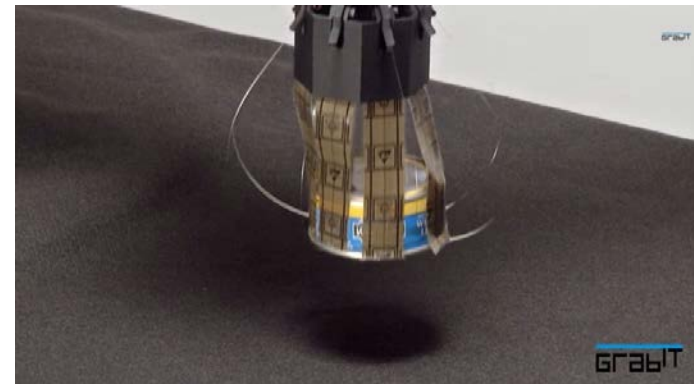
## Biomedical



## Space



## Consumer

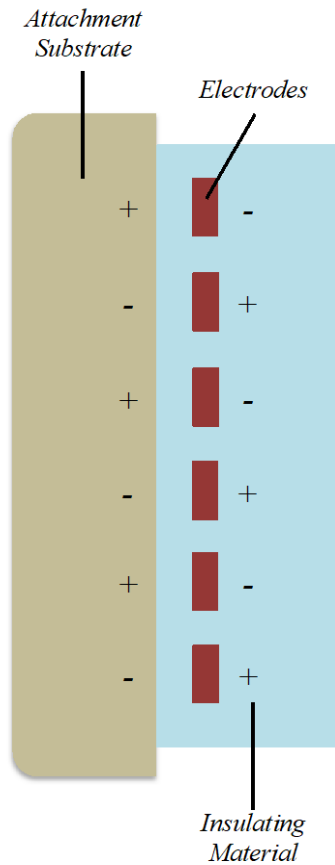


## Introduction



# Electroadhesion Technology

Cross-Sectional View:

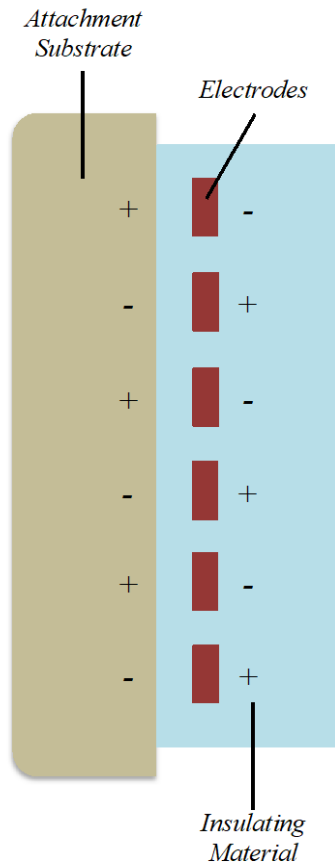


Introduction

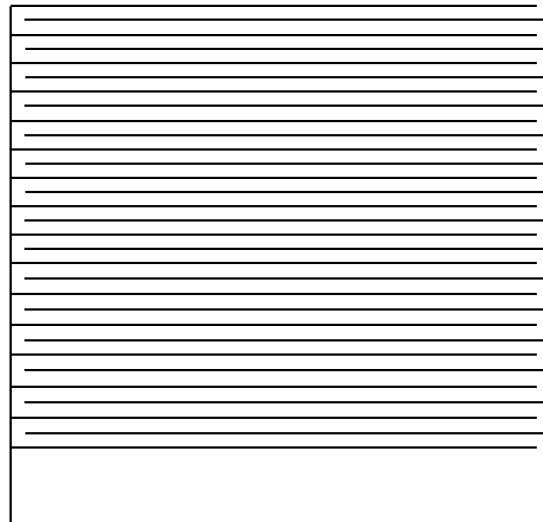


# Electroadhesion Technology

Cross-Sectional View:



Top View:



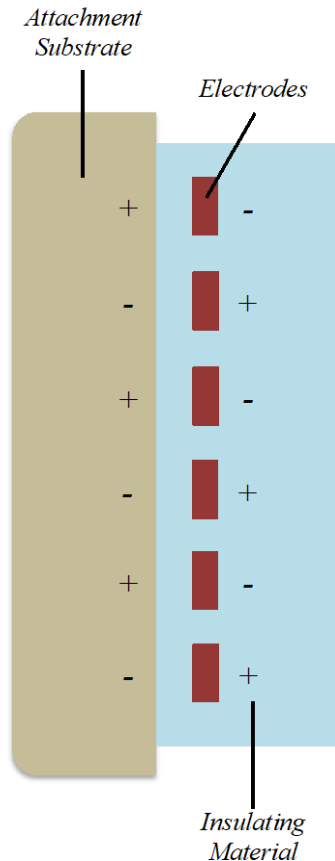
Introduction



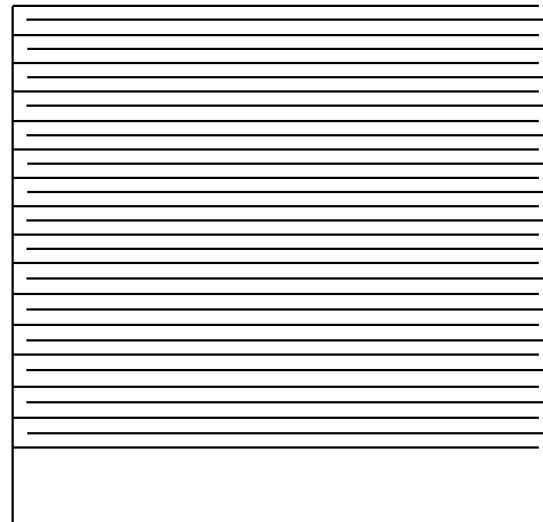


# Electroadhesion Technology

Cross-Sectional View:



Top View:



Governing Equations:

$$P_N = \frac{\epsilon_0 \epsilon_C e^2}{2(2d)^2}$$

$$P_S = \mu_S P_N$$

$\epsilon_0$  Dielectric Constant of Vacuum

$\epsilon_C$  Dielectric Constant of Kapton

$e$  Applied Voltage

$d$  Kapton Thickness

$\mu_S$  Coefficient of Static Friction

Introduction



# Table of Contents

1. Introduction
2. Experiment
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4. Conclusions
5. Further Investigation



# Materials and Method

- Measure maximum shear forces of Electrode adhesion samples at variable input voltages (1 kV – 5 kV)
- Configure samples into proposed geometries and test with air-bearing platforms
- Materials
  - Electrode Material
    - Heavy Duty Aluminum Foil
  - Substrate Materials
    - Anodized Aluminum
    - Bare Aluminum
    - Aluminized Mylar
  - Clamping (Insulating) Material
    - Kapton

Experiment



# Static Response

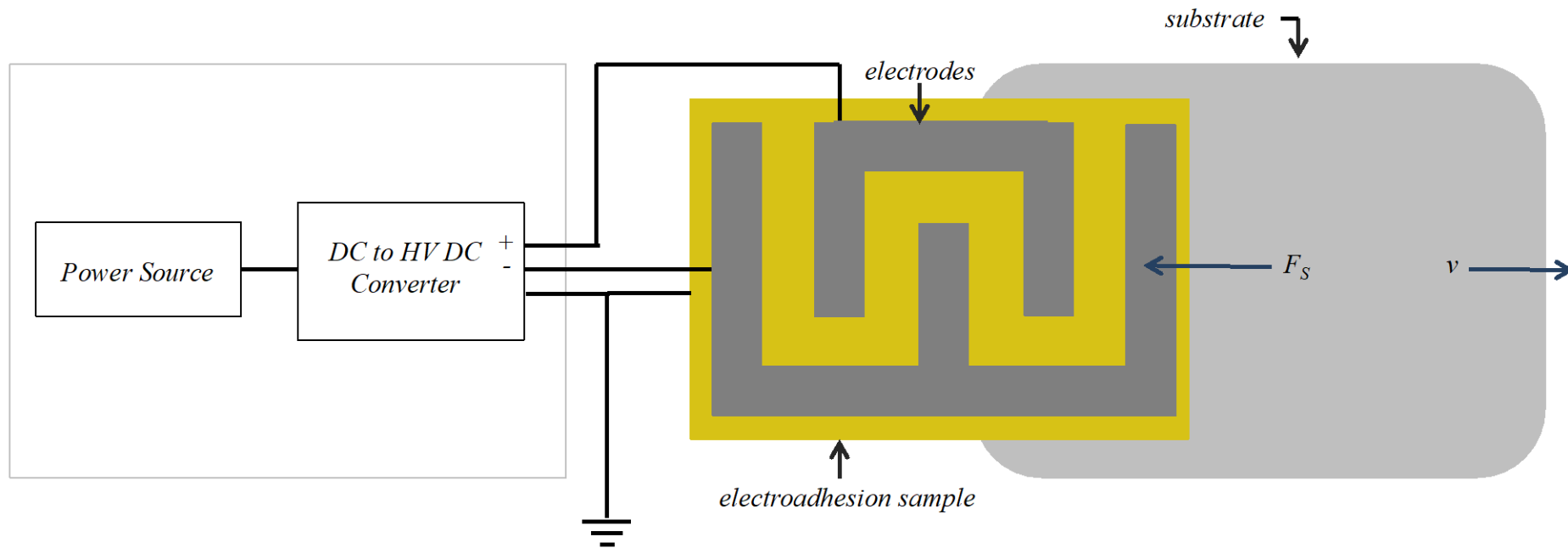


Figure 1: Experimental setup of electroadhesion sample attached to substrate with measured shear force.

Experiment



# Dynamic Application

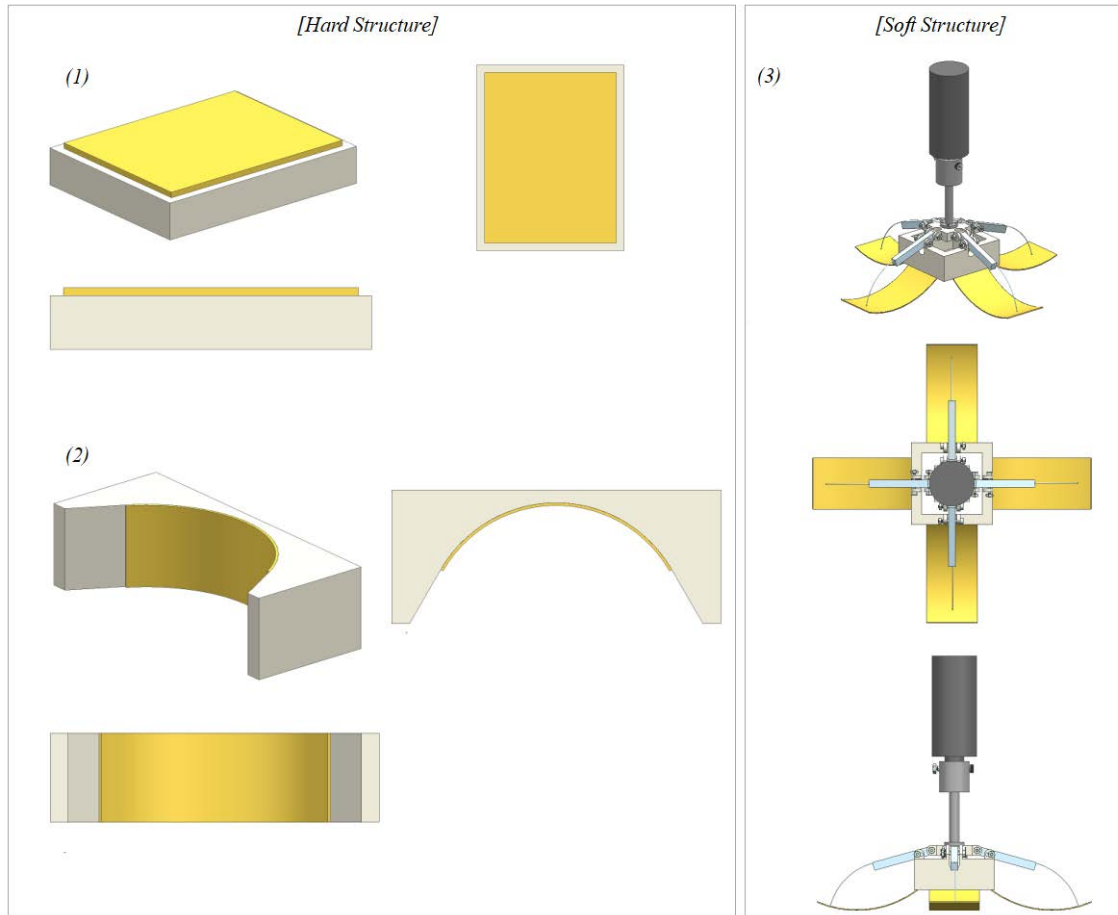


Figure 2: Geometry configurations of samples.

## (1) Flat Plate

- Cubesat
- Flat Spacecraft Side

## (2) Concave Cylinder

- Cylindrical Spacecraft
- Torque Mitigation

## (3) 4-Arm Clamp

- Variety of shapes on Spacecraft
- Other small objects

Experiment



# Dynamic Application

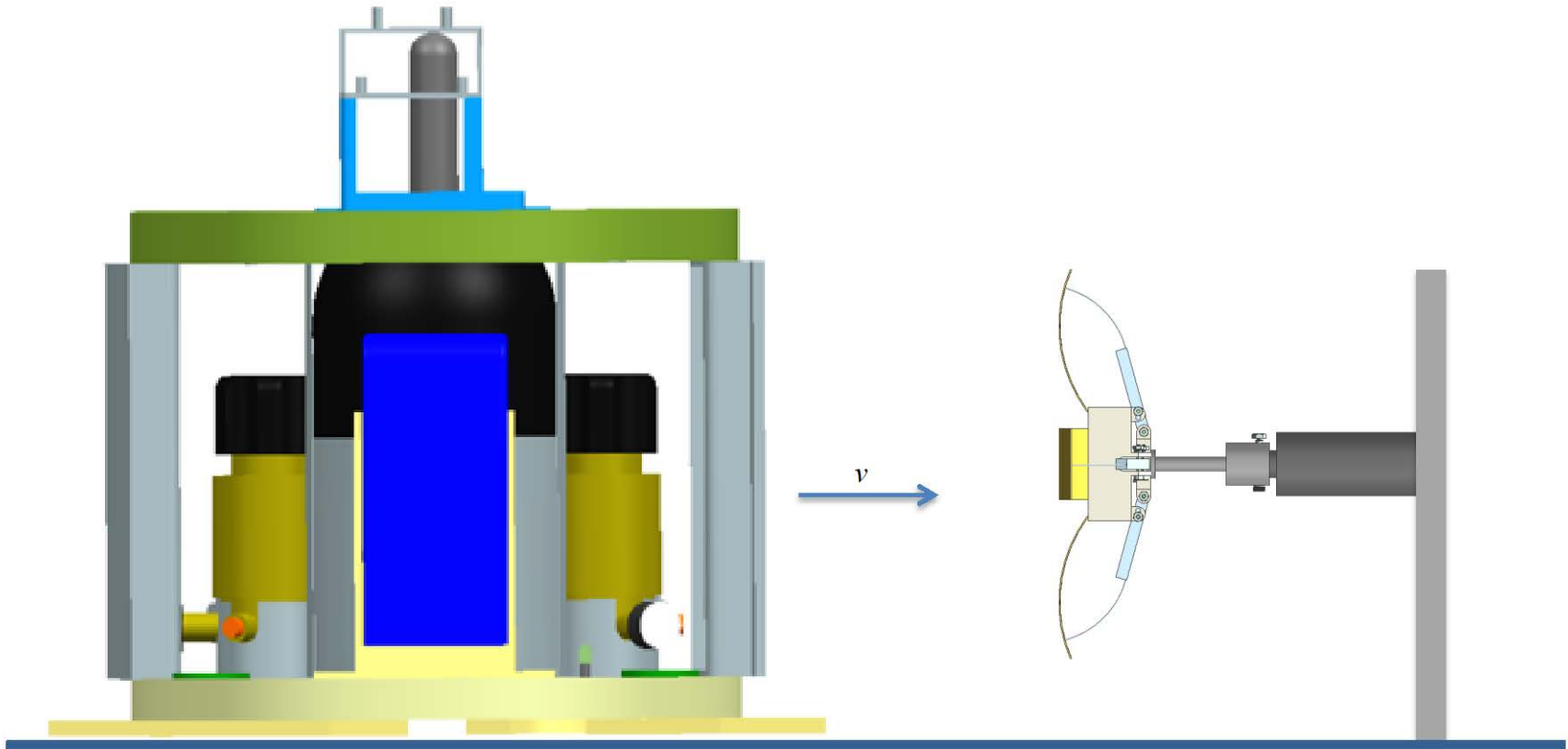


Figure 3: Experimental setup of air bearing platform with attached substrate and electroadhesion device of geometry (3).

Experiment

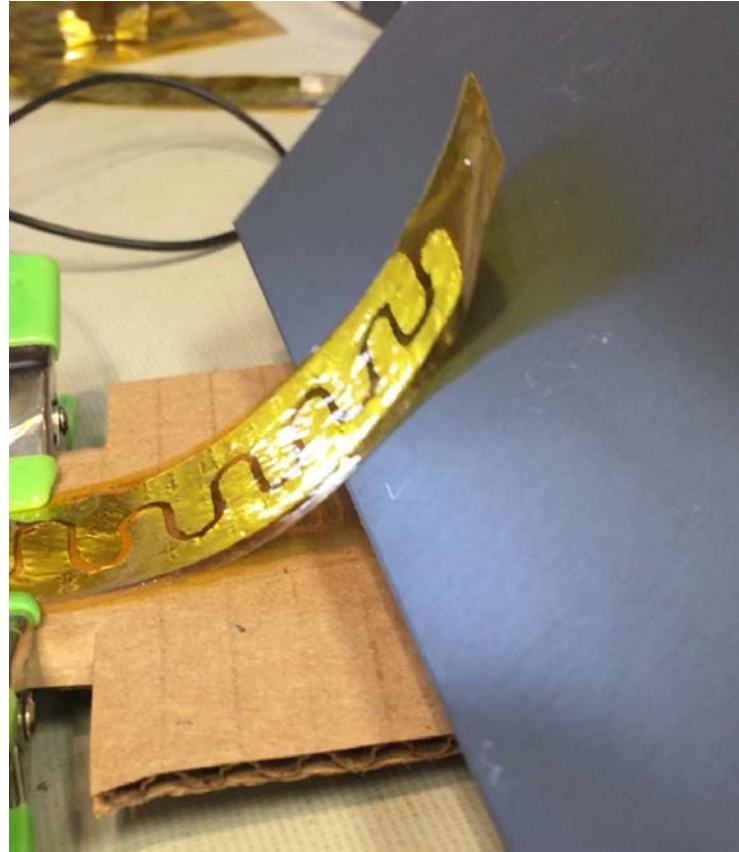


# Table of Contents

1. Introduction
2. Experiment
- 3. Results and Discussion**
4. Conclusions
5. Further Investigation



# Static Response



## Results and Discussion





# Static Response

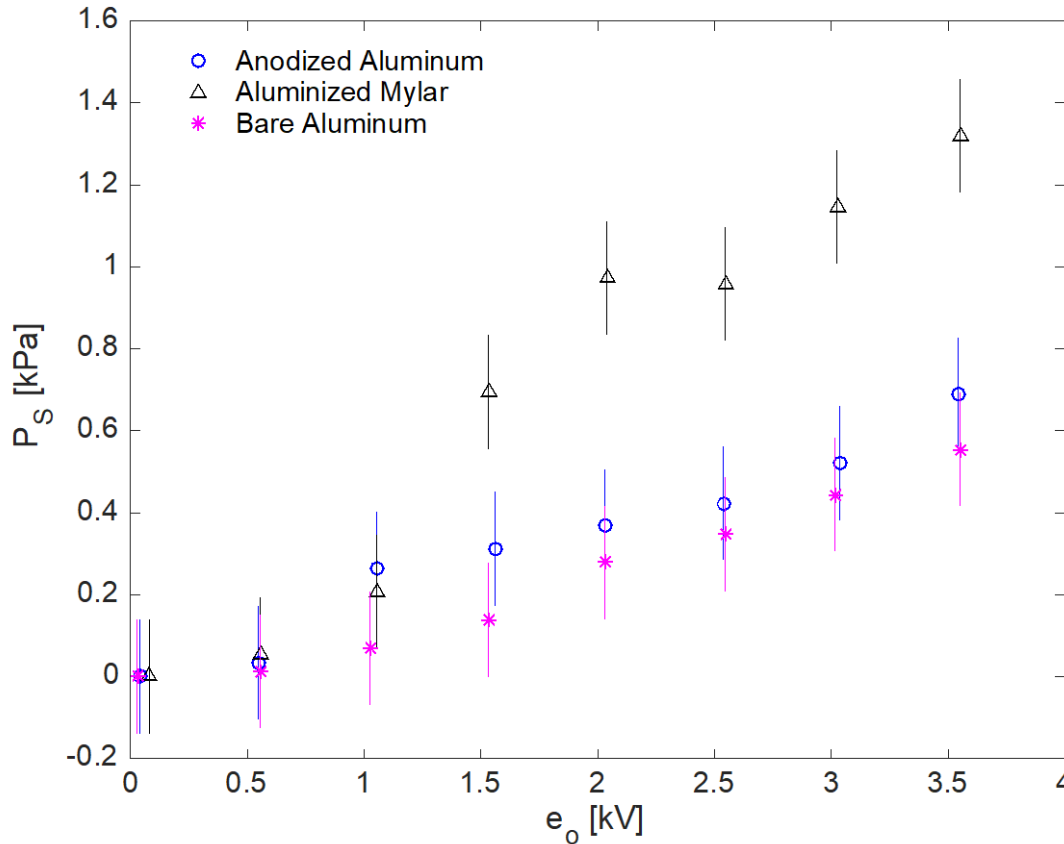


Figure 4: Static shear pressure.

## Aluminized Mylar

- Efficiently conformed to electroadhesion sample
- Largest shear pressure

## Aluminum (Bare and Anodized)

- Rigid substrates
- Air pockets between sample and substrate

## Results and Discussion



# Constructed Geometries

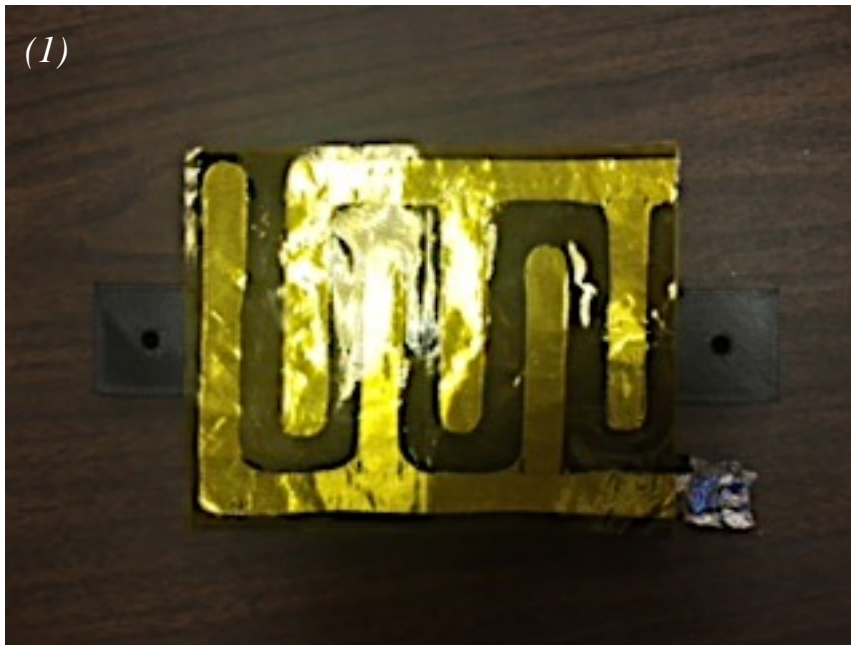


Figure 5: Clamp Geometry (1) (left) and Geometry (2) (right) of electroadhesion samples.

## Results and Discussion



# Constructed Geometries

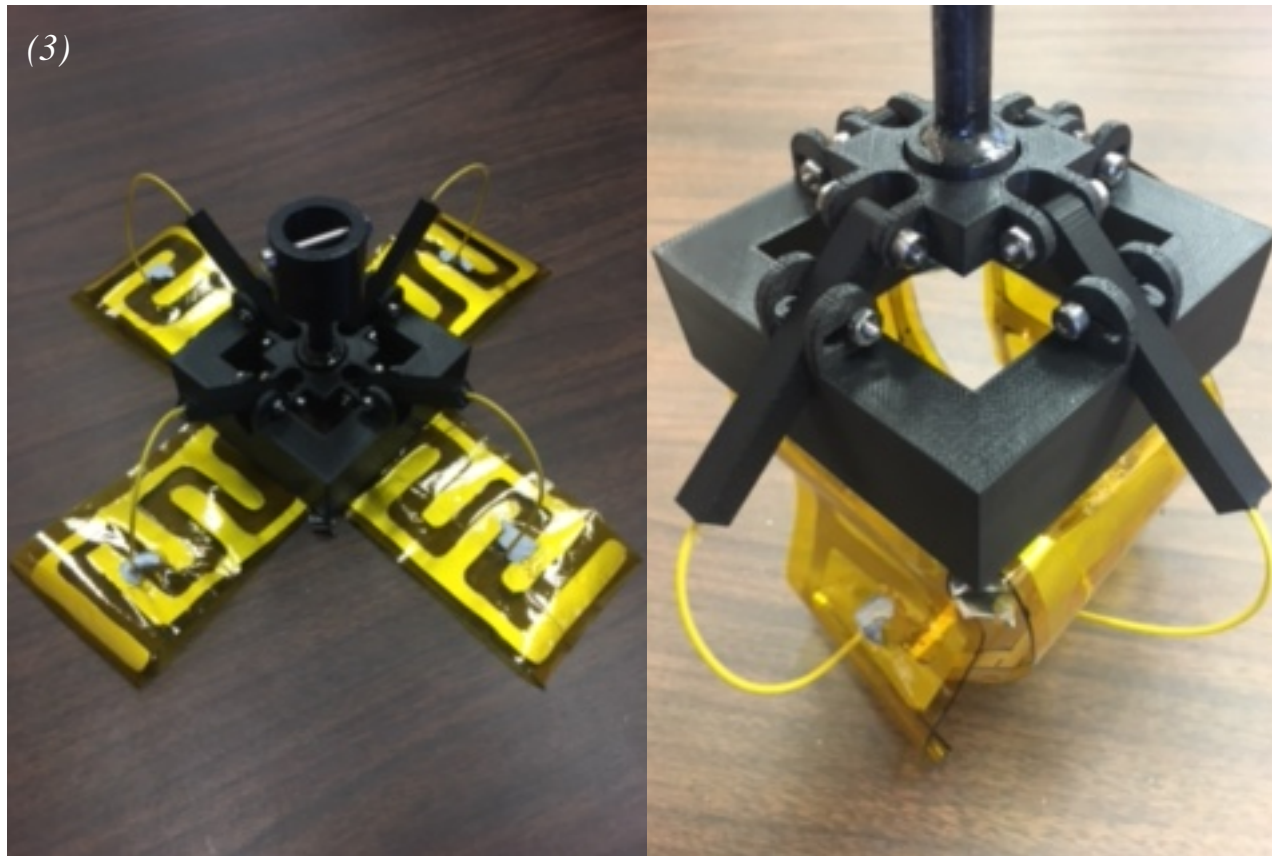


Figure 6: Clamp Geometry (3) of electroadhesion samples.

## Results and Discussion



# Dynamic Application

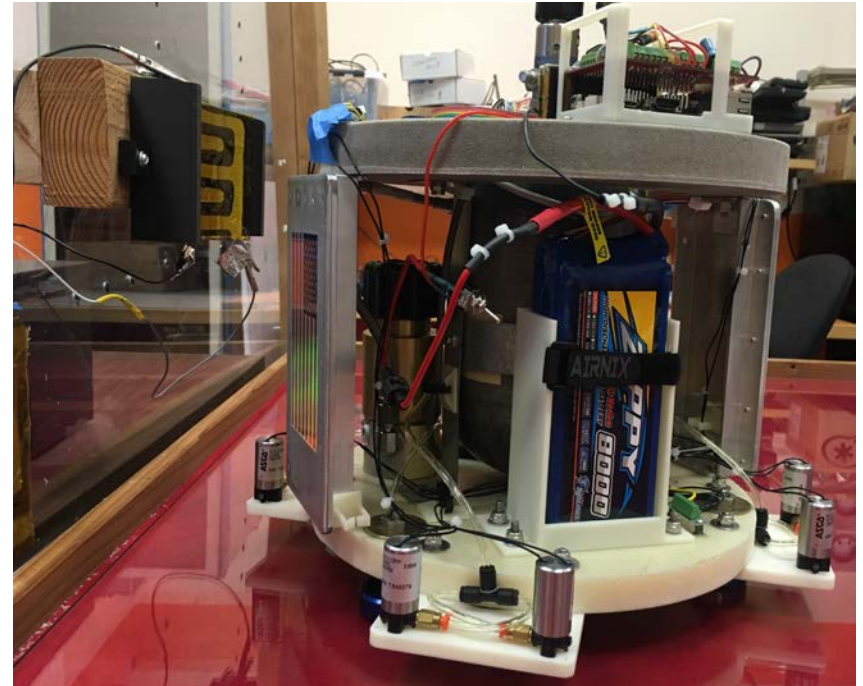
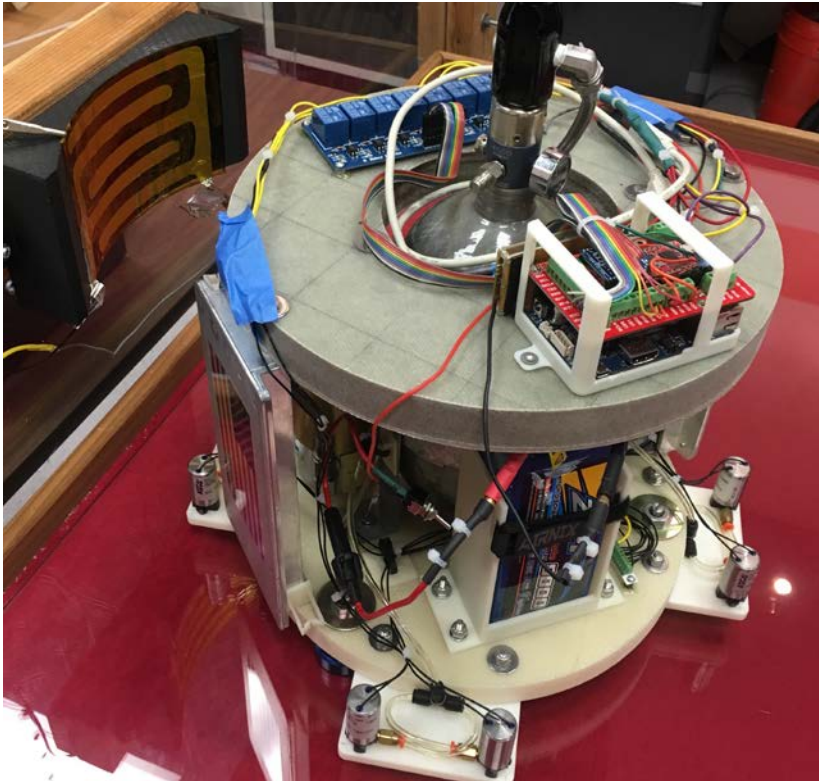


Figure 7: Air-bearing platform isometric and side views.

## Results and Discussion



# Dynamic Application

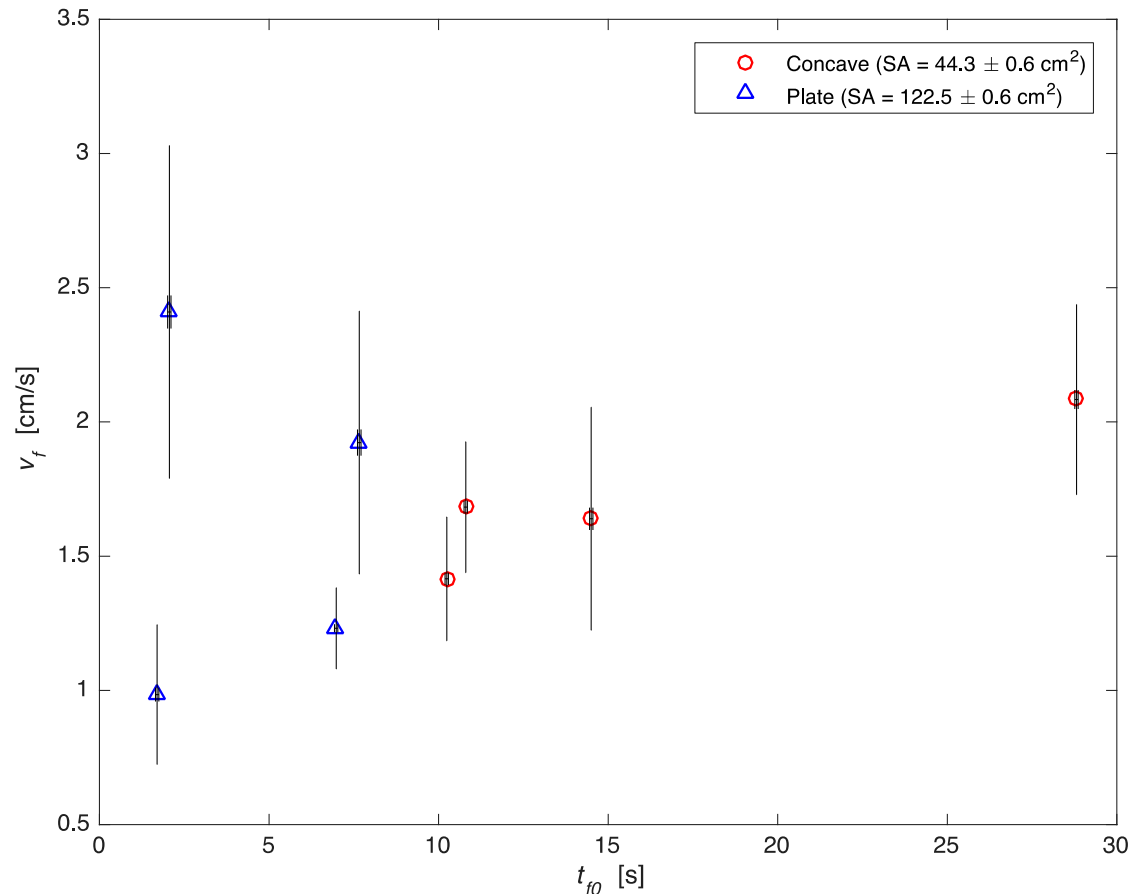


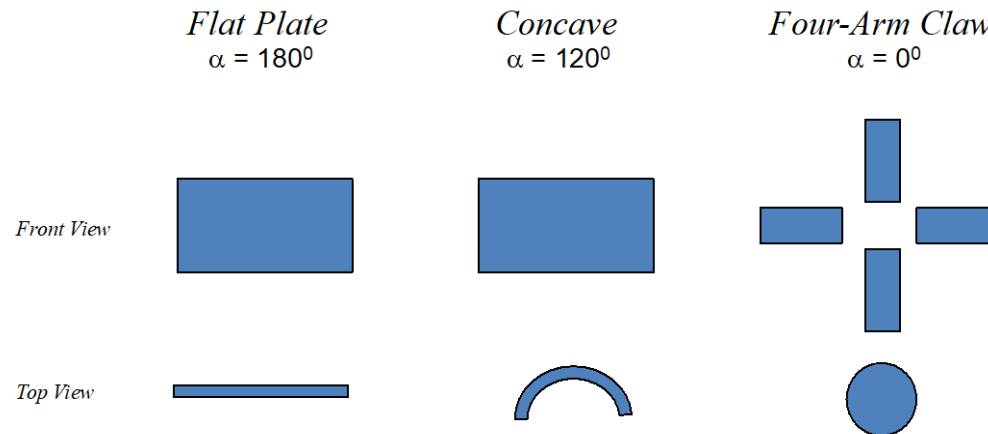
Figure 8: Comparison of time for electroadhesion geometry to stop movement.

## Results and Discussion

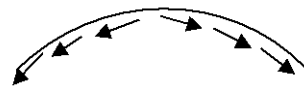




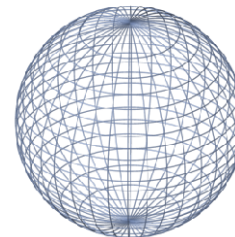
# Proposed Metric for Capturing



Multiple number of shear forces that are opposed to each other across the surface, depending upon angle. For 2D surfaces max angle may be  $180^\circ$ .



Velocity Vector  
of target to  
contact surface  
movement



For a 3D surface, number of shear forces that could oppose each other is greater than  $180^\circ$ , and the third dimension allows for increased contact resistance to movement.

## Results and Discussion



# Table of Contents

1. Introduction
2. Experiment
3. Results and Discussion
- 4. Conclusions**
5. Further Investigation



# Summary of Results

- Superior geometry is dependent on scenario
  - Lag of material from hard structure determined best docking scenarios
  - Implies soft structures are optimal
- Flexible aluminized Mylar material produced greatest shear pressure with electroadhesion sample
- Linear relationship between initial approach velocity, residual motion, and surface area of contact
- A metric is proposed to determine the stop time of initial and residual motion dependent on electroadhesion geometry and contact surface area

## Conclusions





# Table of Contents

1. Introduction
2. Experiment
3. Results and Discussion
4. Conclusions
5. Further Investigation



# Future Research

- Varying Insulating Material
- Manufactured electroadhesion samples to acquire greater shear forces (NASA-JPL)
- Additional sample geometries
- Control algorithms for docking with claw geometry

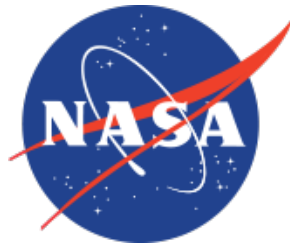


Further Investigation



# References

- [1] T. Bryan, *et al.*, "Innovative Electrostatic Adhesion Technologies," NASA Marshal Space Flight Center, Huntsville, AL, Stanford Res. Inst., Stanford, CA.
- [2] Massachusetts Int. of Technology Space Systems Laboratory. (2014). *SPHERES*. Web. Available: <http://sl.mit.edu>.
- [3] DesignCo Marketing. (2015). *Grabit, Inc.* Web. Available: <http://www.grabitinc.com>.
- [4] J. P. Tellez, *et al.*, "Characterization of Electro-adhesives for Robotic Applications," in Int. Conf. Robotics and Biomimetrics, Karon Beach, Thailand, 2011.
- [5] D. Ruffatto III, *et al.*, "Increasing the adhesion force of electrostatic adhesives using optimized electrode geometry and a novel manufacturing process," Journal of Electrostatics, 2014, pp. 146 - 155.
- [6] R. Pelrine, "Electroadhesive Wall Climbing Robots and more," Microrobot Inspectors. Stanford Res. Inst., Stanford, CA, 2009.
- [7] H. Allison *et al.*, "Electro Adhesion Device," U.S. Patent 6 791 817 B2, Sep. 14, 2004.
- [8] D. F. Ruffatto III, "Hybrid Electrostatic and Micro-Structured Adhesives for Robotics Applications," Illinois Institute of Technology, Chicago, IL, 2015.
- [9] D. Ruffatto III and M. Spenko, "Parameter Optimization of Directional Dry Adhesives for Robotics Climbing and Gripping Applications," in IEEE Int. Conf. Robotics and Automation, Saint Paul, MN, 2012.
- [10] D. Ruffatto III, *et al.*, "Optimization and Experimental Validation of Electrostatic Adhesive Geometry," in IEEE Aerospace Conf., Big Sky, MT, 2013.
- [11] D. Ruffatto III, *et al.*, "Experimental Evaluation of Adhesive Technologies for Robotics Grippers on Micro-Rough Surfaces," IEEE Int. Conf. Robotics and Automation, Hong Kong, China, 2014.
- [12] M. Dadkhah, *et al.*, "A Self-Aligning Gripper Using an Electrostatic/Gecko-Like Adhesive," IEEE Int. Conf. Intelligent Robots and Systems, Daejeon, Korea, 2016.



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